

FIGURE 1.—DEFINITIONS OF TERMS USED IN WASTEWATER EQUATIONS

Main Terms

AMR=Actual mass removal of Table 8 and/or Table 9 compounds achieved by treatment process or a series of treatment processes, kg/hr.

C=Concentration of Table 8 and/or Table 9 compounds in wastewater, ppmw.

CG=Concentration of TOC (minus methane and ethane) or total organic hazardous air pollutants, in vented gas stream, dry basis, ppmv.

CG_c=Concentration of TOC or organic hazardous air pollutants corrected to 3-percent oxygen, in vented gas stream, dry basis, ppmv.

CGS=Concentration of sample compounds in vented gas stream, dry basis, ppmv.

E=Removal or destruction efficiency, percent.

F_{bio}=Site-specific fraction of Table 8 and/or Table 9 compounds biodegraded, unitless.

f_{bio}=Site-specific fraction of an individual Table 8 or Table 9 compound biodegraded, unitless.

F_m=Compound-specific fraction measured factor, unitless (listed in table 34).

Fr=Fraction removal value for Table 8 and/or Table 9 compounds, unitless (listed in Table 9).

Fr_{avg}=Flow-weighted average of the Fr values.

i=Identifier for a compound.

j=Identifier for a sample.

k=Identifier for a run.

K₂=Constant, $41.57 \cdot 10^{-9}$, (ppm)⁻¹ (gram-mole per standard m³) (kg/g), where standard temperature (gram-mole per standard m³) is 20 °C.

m=Number of samples.

M=Mass, kg.

MW=Molecular weight, kg/kg-mole.

n=Number of compounds.

p=Number of runs.

%O_{2d}=Concentration of oxygen, dry basis, percent by volume.

Q=Volumetric flowrate of wastewater, m³/hr.

QG=Volumetric flow rate of vented gas stream, dry standard, m³/min.

QMG=Mass flowrate of TOC (minus methane and ethane) or organic haz-

ardous air pollutants, in vented gas stream, kg/hr.

QMW=Mass flowrate of Table 8 and/or Table 9 compounds in wastewater, kg/hr.

ρ=Density, kg/m³.

RMR=Required mass removal achieved by treatment process or a series of treatment processes, kg/hr.

t_r=Total time of all runs, hr.

Subscripts

a=Entering.

b=Exiting.

i=Identifier for a compound.

j=Identifier for a sample.

k=Identifier for a run.

m=Number of samples.

n=Number of compounds.

p=Number of runs.

T=Total; sum of individual.

[59 FR 19468, Apr. 22, 1994, as amended at 59 FR 29201, June 6, 1994; 61 FR 63629-63630, Dec. 12, 1995; 62 FR 2779, Jan. 17, 1997; 63 FR 67793, Dec. 9, 1998; 64 FR 20195, Apr. 26, 1999]

Subpart H—National Emission Standards for Organic Hazardous Air Pollutants for Equipment Leaks

SOURCE: 59 FR 19568, Apr. 22, 1994, unless otherwise noted.

§ 63.160 Applicability and designation of source.

(a) The provisions of this subpart apply to pumps, compressors, agitators, pressure relief devices, sampling connection systems, open-ended valves or lines, valves, connectors, surge control vessels, bottoms receivers, instrumentation systems, and control devices or closed vent systems required by this subpart that are intended to operate in organic hazardous air pollutant service 300 hours or more during the calendar year within a source subject to the provisions of a specific subpart in 40 CFR part 63 that references this subpart.

(b) After the compliance date for a process unit, equipment to which this subpart applies that are also subject to the provisions of:

(1) 40 CFR part 60 will be required to comply only with the provisions of this subpart.

(2) 40 CFR part 61 will be required to comply only with the provisions of this subpart.

(c) If a process unit subject to the provisions of this subpart has equipment to which this subpart does not apply, but which is subject to a standard identified in paragraph (c)(1), (c)(2), or (c)(3) of this section, the owner or operator may elect to apply this subpart to all such equipment in the process unit. If the owner or operator elects this method of compliance, all VOC in such equipment shall be considered, for purposes of applicability and compliance with this subpart, as if it were organic hazardous air pollutant (HAP). Compliance with the provisions of this subpart, in the manner described in this paragraph, shall be deemed to constitute compliance with the standard identified in paragraph (c)(1), (c)(2), or (c)(3) of this section.

(1) 40 CFR part 60, subpart VV, GGG, or KKK; (2) 40 CFR part 61, subpart F or J; or (3) 40 CFR part 264, subpart BB or 40 CFR part 265, subpart BB.

(2) [Reserved]

(d) The provisions in § 63.1(a)(3) of subpart A of this part do not alter the provisions in paragraph (b) of this section.

(e) Except as provided in any subpart that references this subpart, lines and equipment not containing process fluids are not subject to the provisions of this subpart. Utilities, and other non-process lines, such as heating and cooling systems which do not combine their materials with those in the processes they serve, are not considered to be part of a process unit.

(f) The provisions of this subpart do not apply to research and development facilities or to bench-scale batch processes, regardless of whether the facilities or processes are located at the same plant site as a process subject to the provisions of this subpart.

[59 FR 19568, Apr. 22, 1994, as amended at 59 FR 48176, Sept. 20, 1994; 59 FR 53360, Oct. 24, 1994; 60 FR 18029, Apr. 10, 1995; 61 FR 31439, June 20, 1996; 64 FR 20198, Apr. 26, 1999]

§ 63.161 Definitions.

All terms used in this subpart shall have the meaning given them in the Act and in this section as follows, ex-

cept as provided in any subpart that references this subpart.

Batch process means a process in which the equipment is fed intermittently or discontinuously. Processing then occurs in this equipment after which the equipment is generally emptied. Examples of industries that use batch processes include pharmaceutical production and pesticide production.

Batch product-process equipment train means the collection of equipment (e.g., connectors, reactors, valves, pumps, etc.) configured to produce a specific product or intermediate by a batch process.

Bench-scale batch process means a batch process (other than a research and development facility) that is operated on a small scale, such as one capable of being located on a laboratory bench top. This bench-scale equipment will typically include reagent feed vessels, a small reactor and associated product separator, recovery and holding equipment. These processes are only capable of producing small quantities of product.

Bottoms receiver means a tank that collects distillation bottoms before the stream is sent for storage or for further downstream processing.

Closed-loop system means an enclosed system that returns process fluid to the process and is not vented to the atmosphere except through a closed-vent system.

Closed-purge system means a system or combination of system and portable containers, to capture purged liquids. Containers must be covered or closed when not being filled or emptied.

Closed-vent system means a system that is not open to the atmosphere and that is composed of hard-piping, ductwork, connections and, if necessary, flow-inducing devices that transport gas or vapor from a piece or pieces of equipment to a control device or back into a process.

Combustion device means an individual unit of equipment, such as a flare, incinerator, process heater, or boiler, used for the combustion of organic hazardous air pollutant emissions.